## 10/588523 IAP11 Rec'd PCT/PTO 07 AUG 2006

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

SUGAWARA Atty. Ref.: 925-348

Serial No. Unknown TC/A.U.: Unknown

Filed: August 7, 2006 Examiner: Unknown

For: HIGH-WITHSTAND VOLTAGE WIDE-GAP SEMICONDUCTOR DEVICE

AND POWER DEVICE

August 7, 2006

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## INFORMATION DISCLOSURE STATEMENT

As suggested by 37 C.F.R. 1.97, the undersigned attorney brings to the attention of the Patent and Trademark Office the references listed on the attached form PTO/SB/08a. A copy of each listed foreign patent document and article is attached.

This is not to be construed as a representation that a search has been made or that no better prior art exists, or that a reference is relevant merely because cited.

The Examiner is requested to initial the attached form PTO/SB/08a and to return a copy of the initialed document to the undersigned as an indication that the attached references have been considered and made of record.

Respectfully submitted,

NIXON & VANDERHYE P.C.

H. Warren Burnam, Reg. No. 29,366

HWB:jsm

901 North Glebe Road, 11th Floor

Arlington, VA 22203-1808

Telephone: (703) 816-4000 Facsimile: (703) 816-4100

1102947

40/500523

Sheet 4	'of 1 '	IAP11 Rec'd PCT/PTO 07 AUG 2006						
INFORMATION DISCLOSURE CITATION  (Use several sheets if necessary)		ATTY. DOCKET NO. 925-348		SERIAL NO.				
				Unk				
		APPLICANT						
		SUGAWARA						
		FILING DATE		TC/A.	ر.			
		August 7, 2006		Unknown				
		U.S. P	PATENT DOCUMENTS					
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME		CLASS	SUBCLASS	FILING DATE IF APPROPRIAT	
	6.054.752	4/2000	Liore et el		1		I	

KAMINER	· • • • • • • • • • • • • • • • • • • •		S. PATENT DOCUMENTS		<del></del>		DATE
NITIAL T	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	IF APPR	OPRIA1
	6,054,752	4/2000	Hara et al.				
			(Corresponds to JP 11-074524)				
	5,969,400	10/1999	Shinohe et al.	1			
			(Corresponds to JP 08-293618)				
			- Company of the Comp				
					-		
+		-					
,							
					-		
<u> </u>	•	FORE	IGN PATENT DOCUMENTS				
						TRANS	LATIO
	DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
T	11-74524	3/1999	JР				
	8-293618	11/1996	JР	<u> </u>	<u> </u>		
	0 2/3010	11/13/0					
				<u> </u>	<del> </del>		
-							
				-			
						<del></del>	
L							
			luding Author, Title, Date, Pertinen	t pages, e	tc.)		
			22005/001705 dated 10 May 2005.				
			ology and Applications, High-Withstand	Voltage FE	Γ, Nikkan Ko	gyo Shir	nbuns
	March 31, 2003, pp. 218						
			of 3.1 kV 4H-SiC Asymmetical GTO Thyr	istors, Mate	erials Science	Forum,	vols.
	389-393, 2002, pp. 1349					· · ·	
			and Phosphorus Implanted, Planar, High	-Voltage 4F	i-SiC Junctio	n Kectifi	ers,
	Materials Science Forun	ı, vols. 338-34	2, 2000, pp. 1331-1334.				
	<u> </u>	· · · · · · · · · · · · · · · · · · ·					
				-			
					-		

\*Examiner Date Considered Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.